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# Revolutionary SiC-based Micro-MEMs Cryogenic Probing Solution down to 2K

13795 FRONTIER COURT, BURNSVILLE MN 55337, USA | (952) 232-1700 | CELADONSYSTEMS.COM

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Community of On-Wafer Test & Reliability Experts



## **Design and Fabrication of a SiC**based MEMS Probe Die

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#### **Motivation and Technical Objectives**

#### Nielson Scientific

Probe card for testing multiple nearest-neighbor pixels in a cryogenically cooled IR focal-plane array prior to ROIC attachment

- Cryogenic operation
- Probe tip pitch to match pixel pitch
- Transparent probe card for visual alignment
- Tip compliance behavior to match traditional probe tips
  - Tip force of 15 40  $\mu N/\mu m^2$
  - Tip displacement of 25 75  $\mu m$  at desired tip force



#### Low-band-gap infrared detector array e.g., Hg<sub>x</sub>Cd<sub>1-x</sub>Te, InSb

### Readout integrated circuit (ROIC)



#### **Conceptual Design**

#### Nielson Scientific



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#### Nielson Scientific

<b>Operating</b>	Tensile	Thermal	Density
<b>Temperature</b>	Strength	Conductivity	
~1800°C	1.5 GPa	490 W/m*K	3.21 g/

- Very high thermal conductivity
- Chemically inert
- Maintains high strength through operating temperature range
- Wide bandgap semiconductor (3.23 eV)
- Transparent to visible and IR light (~2.7 optical index)
- Extremely hard (9.5 Mohs hardness)
- Low coefficient of thermal expansion
- Robust to radiation
- Very low helium diffusion rates

# y Young's Poisson's Modulus Ratio





#### **Probe Card Mechanical Design Concepts**

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#### **Thermal Cooling Displacements Due to PCB/SiC CTE Differences**

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#### **Thermal Cooling Stresses**

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- SiC tether stress is less than 30 MPa without flexures in PCB
- SiC tether stress is less than 10 MPa with flexures in PCB
- Max stress happens in solder due to material differences





### **Solder Cooling Stresses**

### Nielson Scientific

- Stress is reduced for taller, skinnier solder bumps
- Multiple small contact points improve mechanical connection robustness against thermally induced stresses







#### 200 MPa

### **FEA Analysis of a 50 µm Displacement**

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#### Front/Back Traces, Vias, and Probe Tips

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# **Turning a SiC Die into a Probe Card**

**Dalton Roehl** 

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### CEL^DO<sup>®</sup> PCB Attachment

- The Flexure PCB is attached to the SiC die using a low temp solder to form a mechanical and electrical connection.
- The flexures within the PCB mitigate the radial mechanical stress from the cryogenic shrinkage.
- The 6-point solder positions provide a strong yet flexible connection.



Flexure PCB

SiC Die

m a mechanical and electrical connection. ne cryogenic shrinkage.







- The finishing process for the product is to terminate the Flexure PCB to a usable interface.
- This has been done by either direct cable out, or to a larger PCB







### **CEL^DO Finished Product**

#### **Key Features**

- Cryogenic Probing expected down to 2K
- Clear Optical Path for top-down alignment "See-through".
- MEMS style probes for pad arrays.
- Small probe tips at 8  $\mu m$  diameter
- $\bullet$  Extremely tight pitch down to 20  $\mu m.$
- Future plan for hundreds of probes.









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# THANKS **For Your Attention**

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### CUG011 Reliable Solutions for Cryogenic On-Wafer Test

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## Why Cryogenic On-Wafer Test?

Cryogenic test requirement [4K, 77K common]

 Current technology and medical advancements are requiring the need for challenging cryogenic tests with higher throughput.

Hardware to physically handle DUT, Wafer, or Sample

 For optimal cryogenic test, a cryogenic probe station is used to handle and thermalize the DUT, Wafer, multiple-samples, or single die/chips.

> Hardware to electrically test DUT, Wafer, or Sample

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 To take electrical measurements, probes and probe cards are used to contact the DUT, Wafer, or Sample to transpose the signal into a larger environment to interface to test hardware.









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## **CELADON** Cryogenic Probe Card Types

- Cryostat with micro-positioners
- Cryostat without micro-positioners
  - Lower cost, lower facility resources, lower throughput
- Cryoprober with moving chuck [wafer]
- Cryoprober with moving chuck [singulated die / waffle pack]
  - High cost, lots of facility resources needed, higher throughput





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## **Cryostat with micro-positioners**

- Similar to standard on-wafer lab probe with micropositioners, a cost-effective method to test on-wafer at cryogenic temperatures is to have a positioner arm go through the cold chamber wall.
  - This positioner would then have either a "MiniTile" or a "VersaTile" depending on the application and probe approach requirements.
- Considerations for designing probe cards for cryogenic applications:
  - Material
  - Plating
  - Wiring
  - Strain Relief





## **CELADO Cryo probe card in room temp SiPh Application**



Forbes 2022 "PsiQuantum Has A Goal For Its Million Qubit Photonic Quantum Computer To Outperform Every Supercomputer On The Planet"





- In some applications, due to the nature of the test, a positioner arm cannot be used
  - Need to reach lower temperatures
  - Layout not compatible with MiniTile or VersaTile
- For this, Celadon developed the "MobileProbe"





# **CEL^DO**<sup>"</sup> **Functionality**

- The Celadon MobileProbe<sup>™</sup> uses a kinematic system of holes, tapered pins, and a precise fiducial to ensure repeatable and accurate probing. The integrate bumper stops ensure the card is not crashed or overdriven to the point of probe damage.
  - Celadon has not tested long-term touchdown count.
  - Celadon can integrate TDS probes and Silicon Diode Thermal Sensor feedback in this system.
  - Celadon may modify architecture to include PCB with components.
  - Celadon may design to test multiple chips at once.





#### CONFIDENTIAL

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## **CELADON** MobileProbe Images





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- For this level of cryo probing, the entire chamber is a vacuum; thus, you can no longer use a vacuum chuck to hold the wafer.
  - Sometimes the chips are placed in a waffle pack
  - Sometimes the chips are held down with a small clip
- The result being that the probe card "toe drop" must be significantly more than a standard Celadon card.
  - [Normal is 250µm toe length, some cryo systems need **1,250µm**!]







#### **CONSIDERATIONS FOR TESTING AT 4K AND BELOW**

• Cryogenic cables are specially selected for both thermal considerations and signal integrity. Some signals are more sensitive, requiring a larger coax wire. Less sensitive signals can go through very small hookup wires to minimize thermal mass.











• For a totally non-ferrous solutions, Celadon had to developed a good way to solder Wre [Tungsten] Rhenium] probes to a PCB. Normally this would be Nickel plated.

- Custom stiffeners [thermal mass reduction]
- Custom nonmagnetic plating processes







### **CELADON** Many Different Styles of Cards



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